

Sheet 2 of 2

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 05542-552001	Application No. 10/732,966
	Applicant Chen et al.			
	Filing Date December 10, 2003		Group Art Unit Unknown	

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AY	2 336 121 A	10/13/99	Great Britain				

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AZ	"SPM's PPS Ring Sales History", January 1997 thru November 1999
	AAA	Yuan, et al., A novel Wafer Carrier Ring Design Minimizes Edge Over-Polishing Effects for Chemical Mechanical Polishing, June 27-29 1995 VMIC Conference, 1995 JSMIC 104/95/525, pp. 525-527.

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Disclosure Form (PTO-1449)